

The Construction of a Deposition Chamber for the In-Situ Study of Thin Metal Films

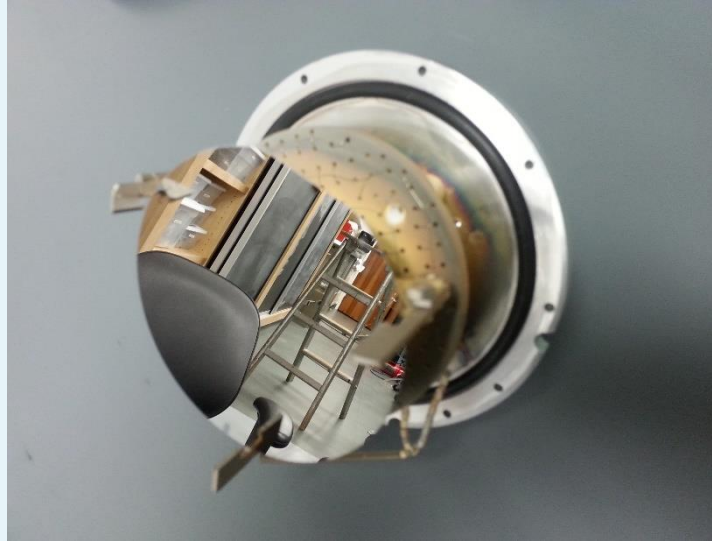
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Outline

- ▶ Thin films
- ▶ Commercial use
- ▶ Research
- ▶ Deposition Chamber
- ▶ Current state and future plans

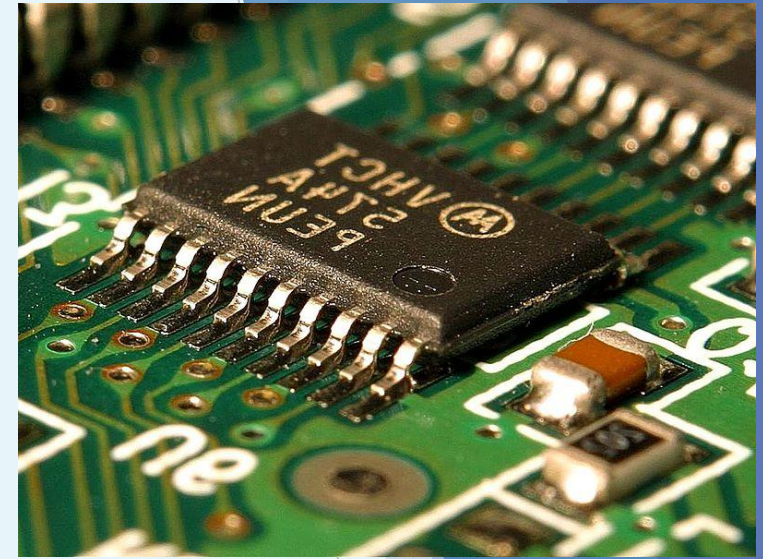


<http://www.lorextechnology.com/accessories-for-security-cameras/250GB-SATA-security-certified-DVR-hard-drive/1863.p>



Thin Metal Films

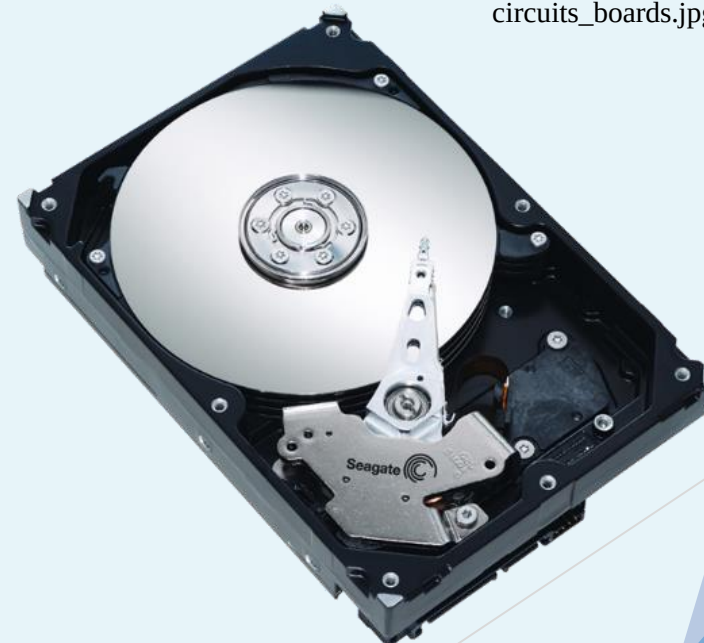
- ▶ Thickness $\ll$ length and width
- ▶ Commercial use



http://commons.wikimedia.org/wiki/File:Computer_chips_circuits_boards.jpg



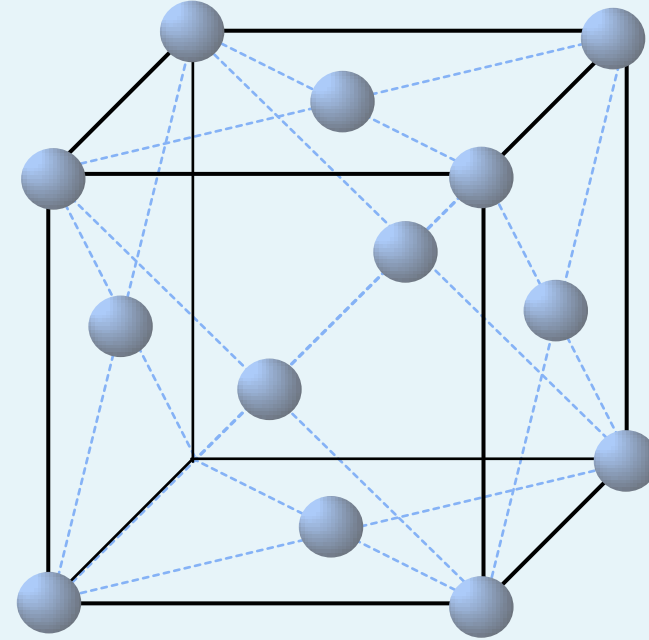
<http://uncyclopedia.wikia.com/wiki/File:Cellphone.png>



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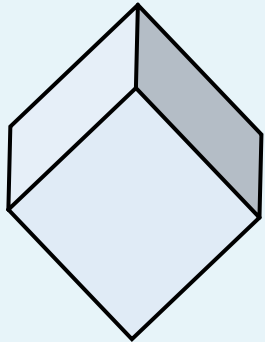
Crystal Lattice Structure

- ▶ Face Centered Cubic

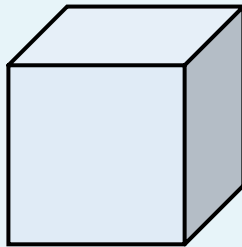


- ▶ Miller Indices

- ▶ 1 1 1

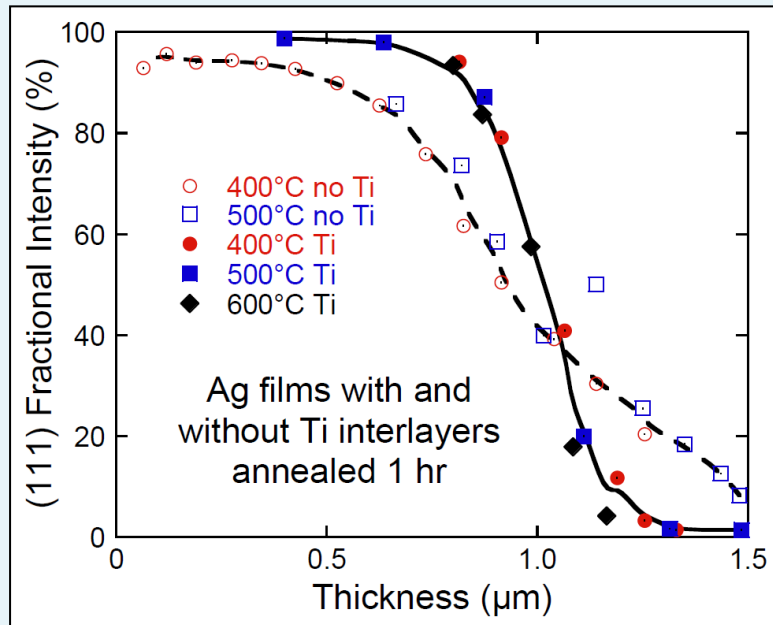


- ▶ 1 0 0

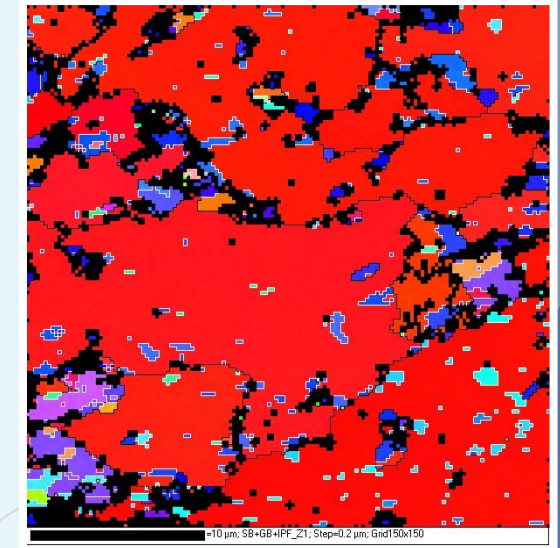
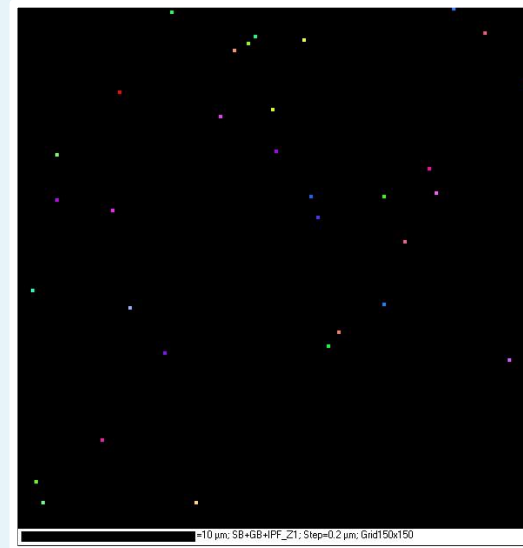


Texture Transformation in Thin Films

- ▶ Transformation from (1 1 1) to (1 0 0)
- ▶ Driving forces behind texture transformation
- ▶ Prevailing Model



Data taken in 2009 at Cornell University by Houghton College students

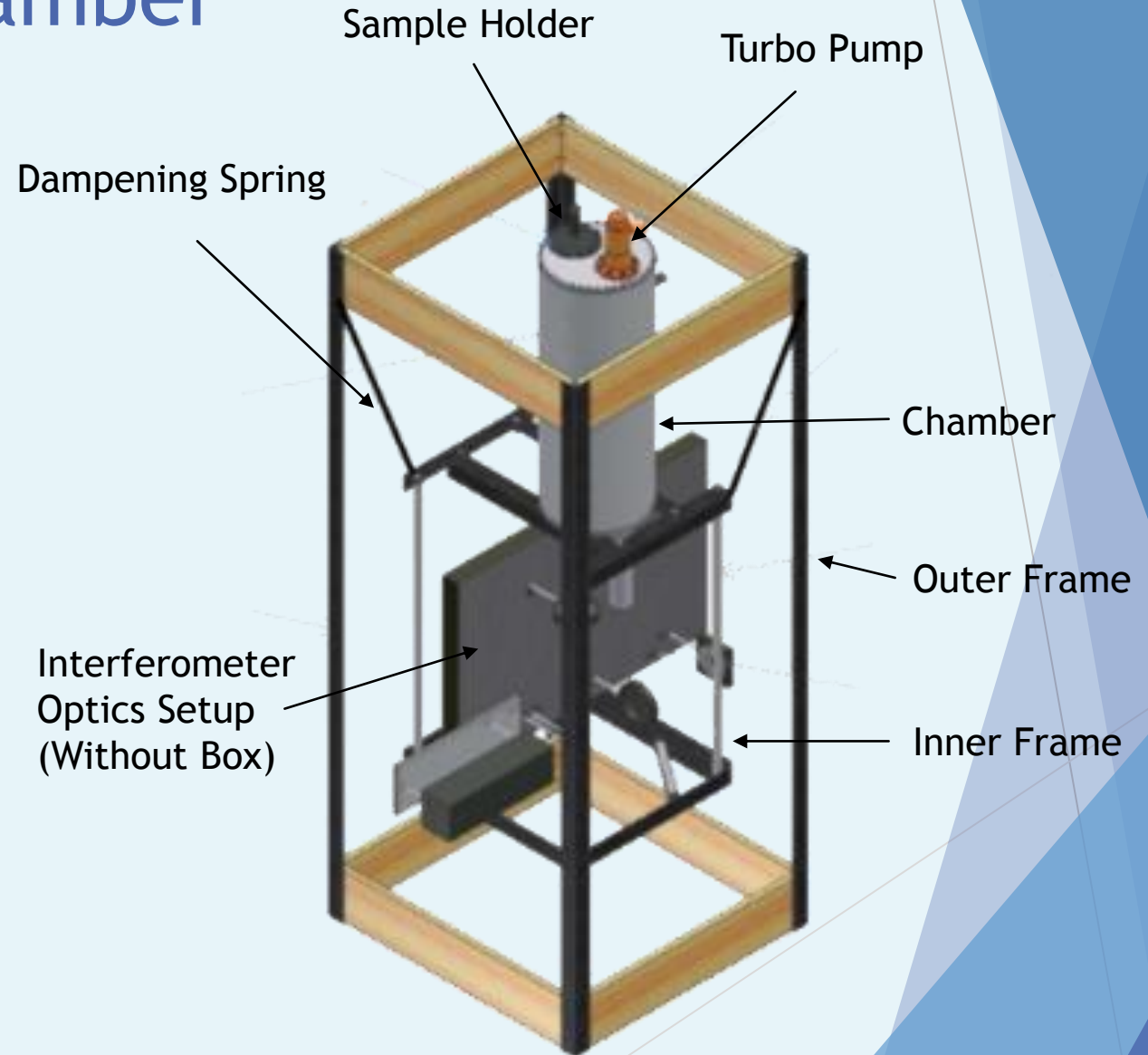


EBSD images of 1800 nm film with Ti, before and after 50°C anneal for 30 hours.

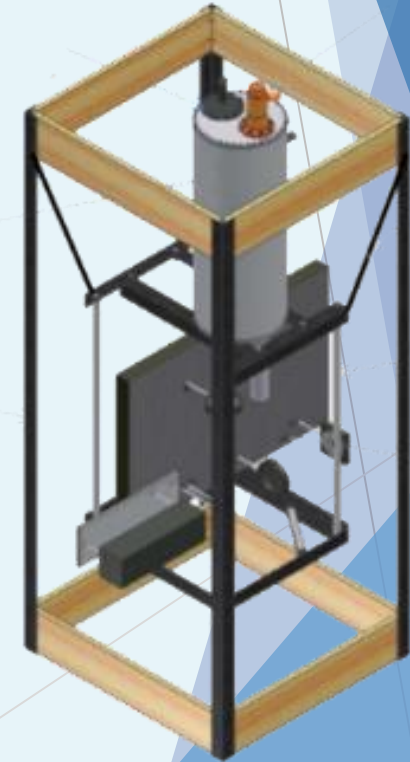
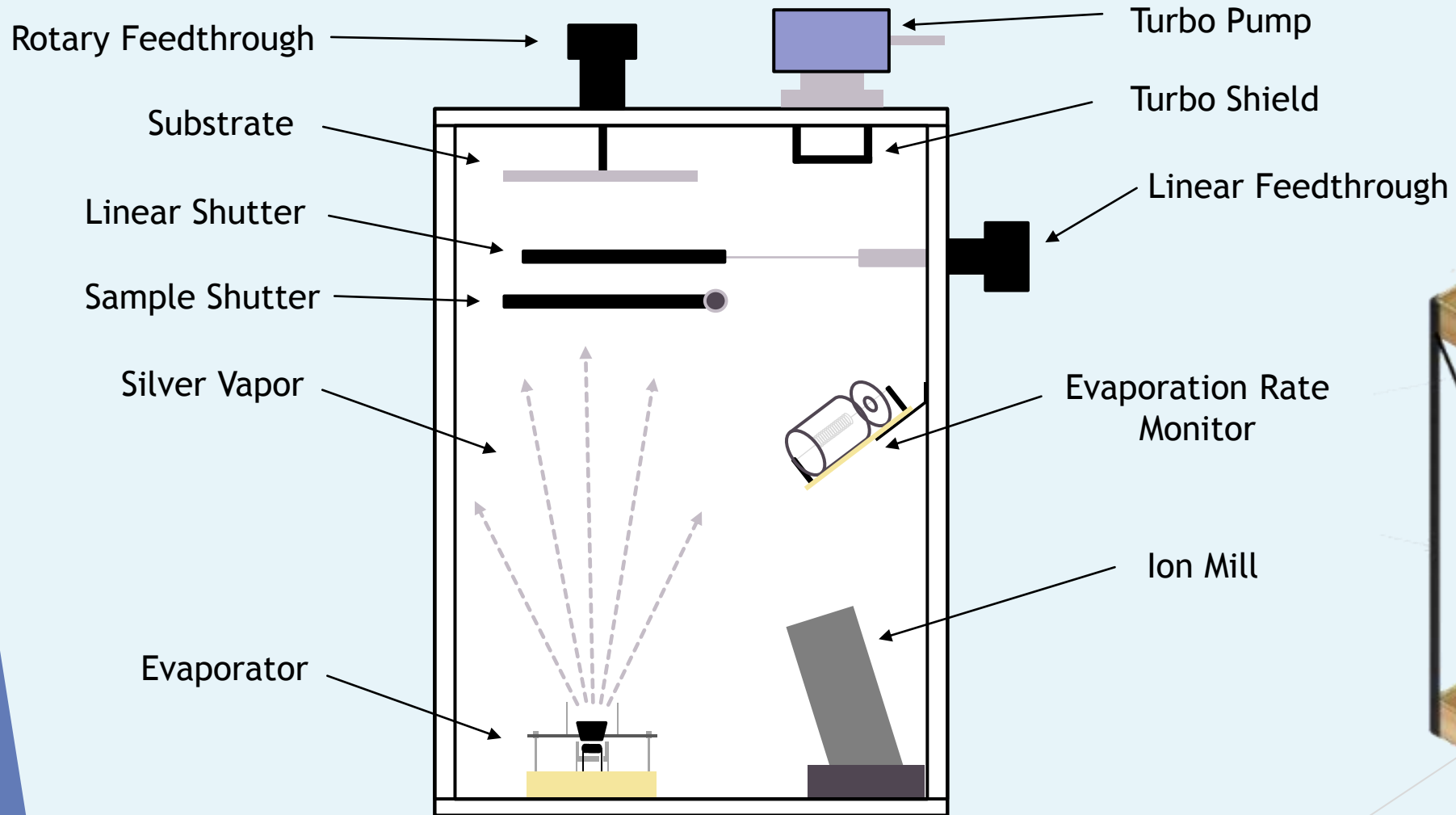
Motivation

- ▶ Build an Apparatus that will allow us to study:
 - ▶ Grain Orientation
 - ▶ In-situ topography
 - ▶ Texture transformation in thin films
 - ▶ Forces driving texture transformation

The Deposition Chamber



The Deposition Chamber



Vacuum Pumps

- ▶ Rough

- ▶ 3×10^{-3} Torr

- ▶ Turbo

- ▶ 9×10^{-8} Torr

- ▶ Ion

- ▶ Reduce vibration while Imaging



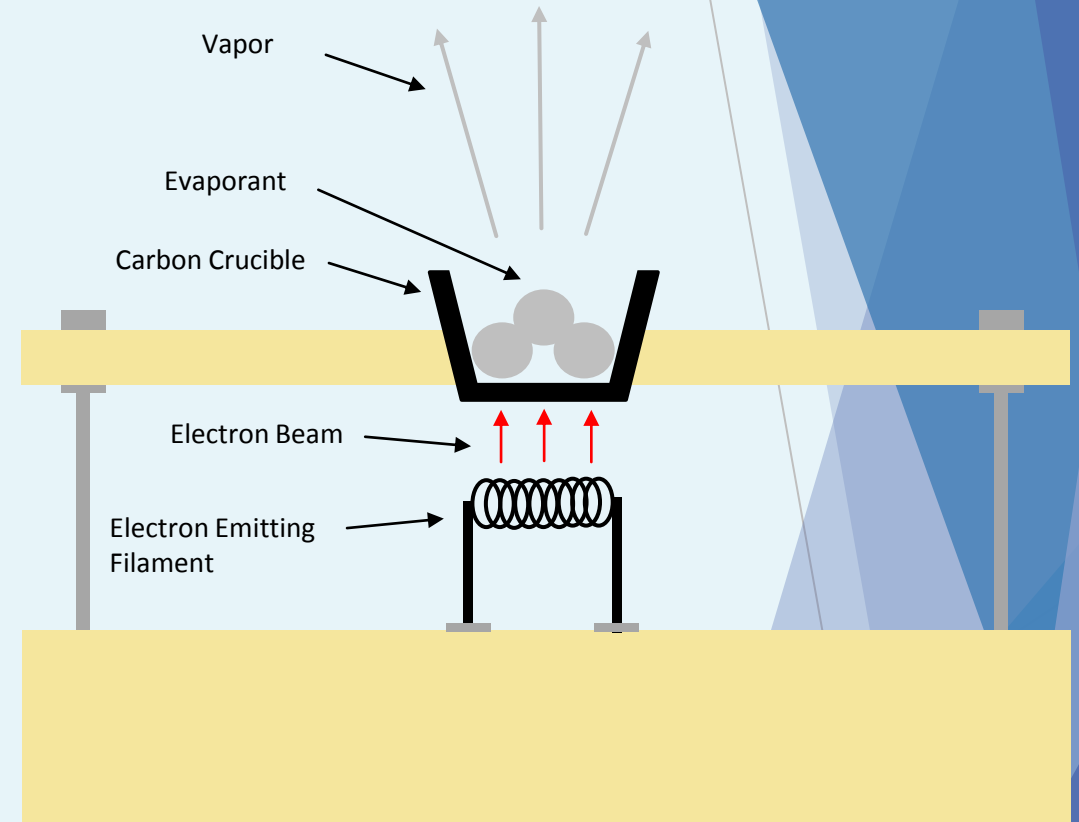
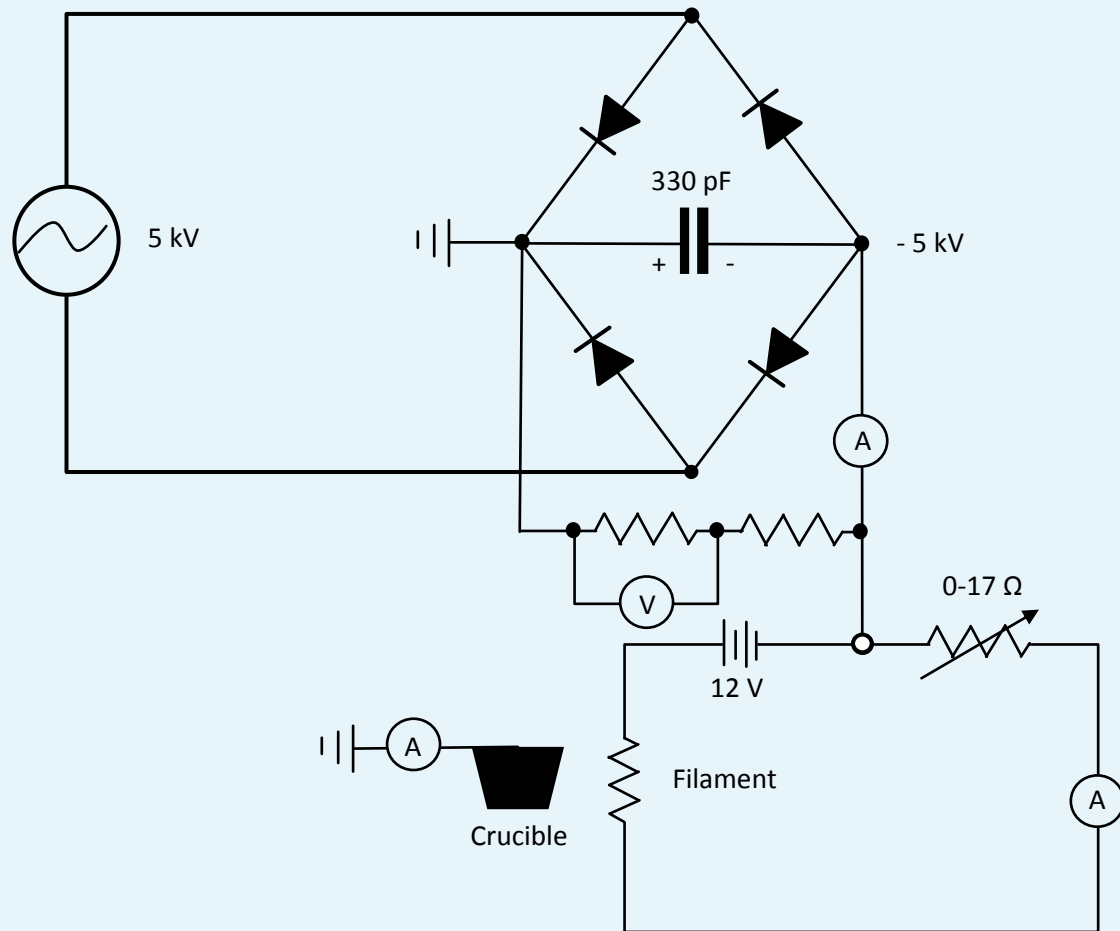
Roughing pump used at Houghton College



Turbo pump attached to top of chamber

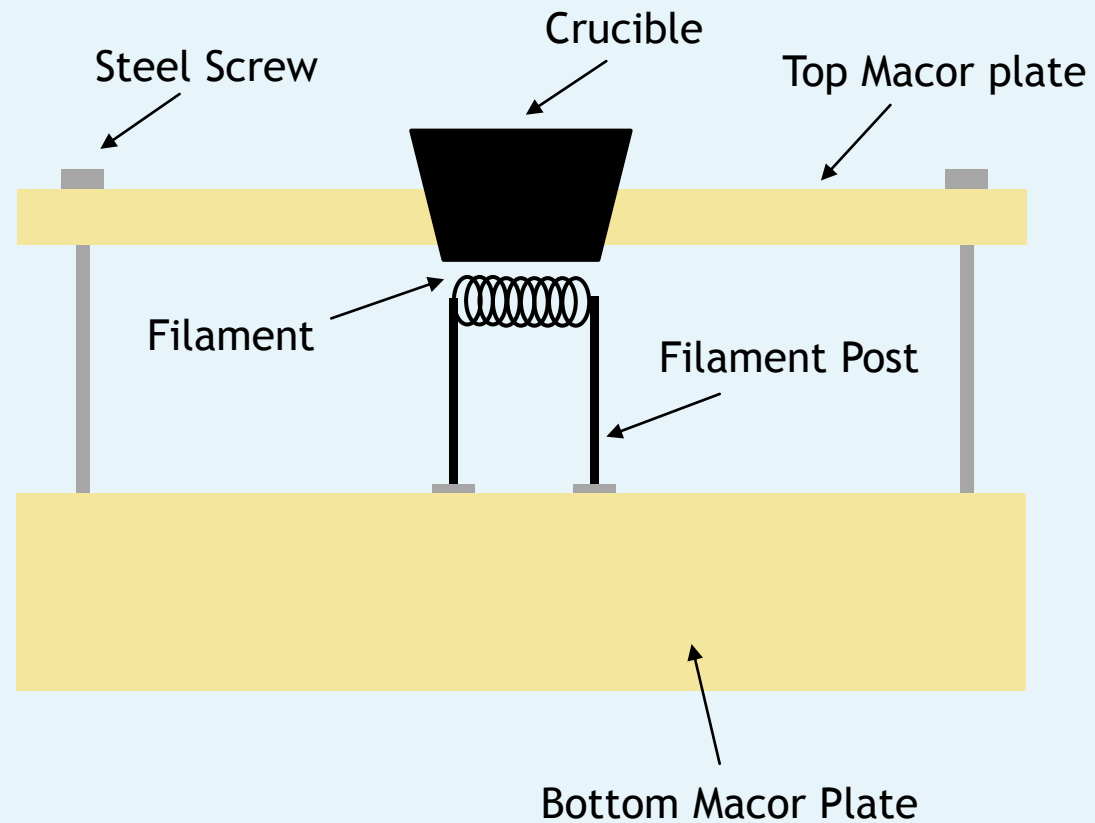
Physical Vapor Deposition

► Electron beam heating



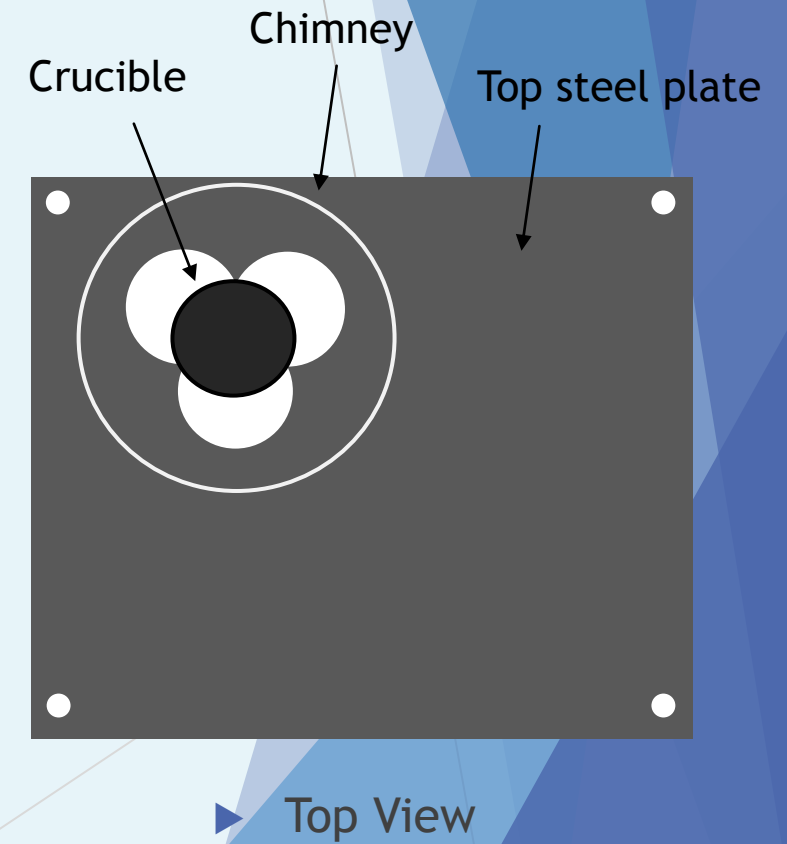
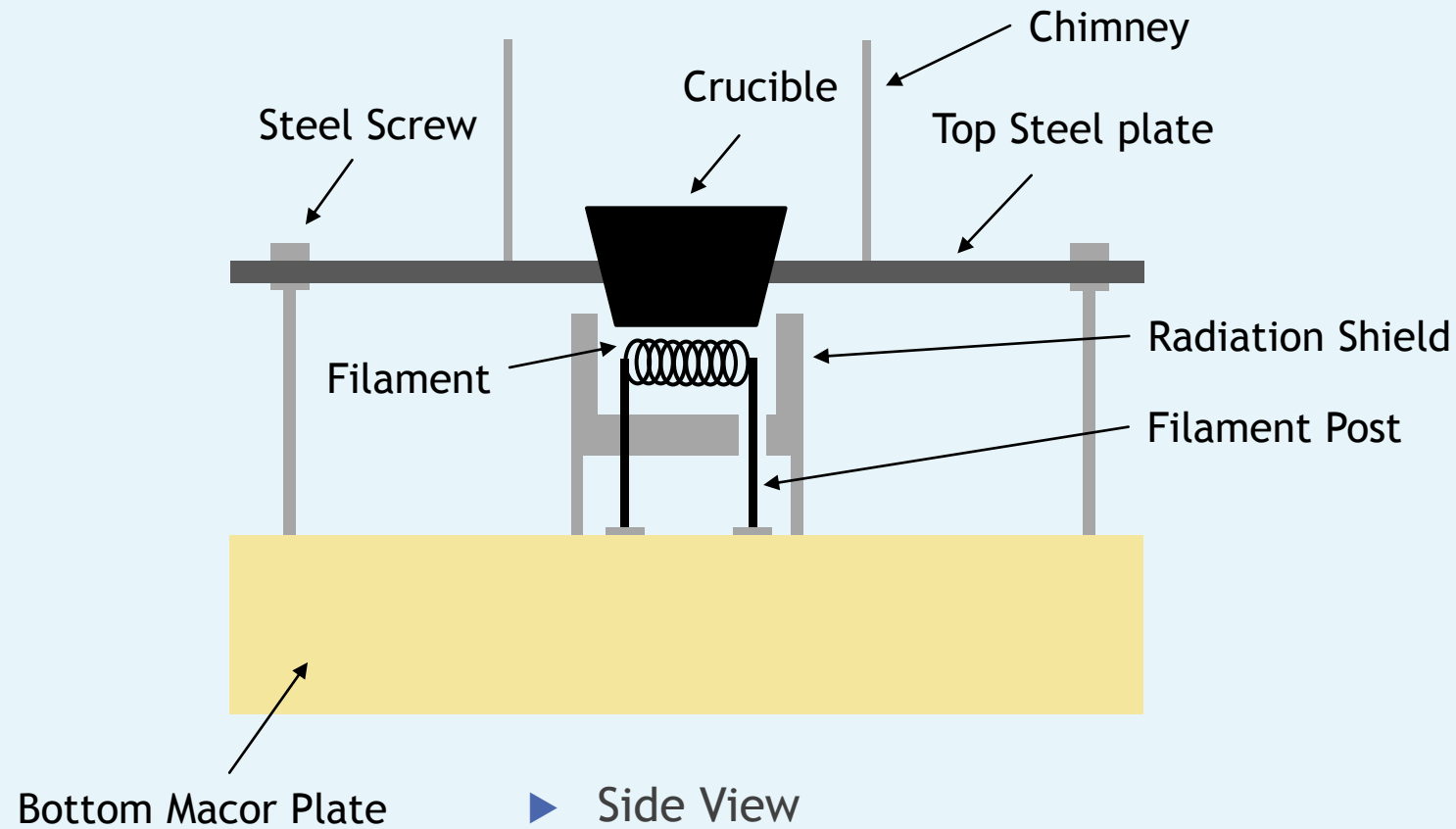
Evaporator

► Original Design

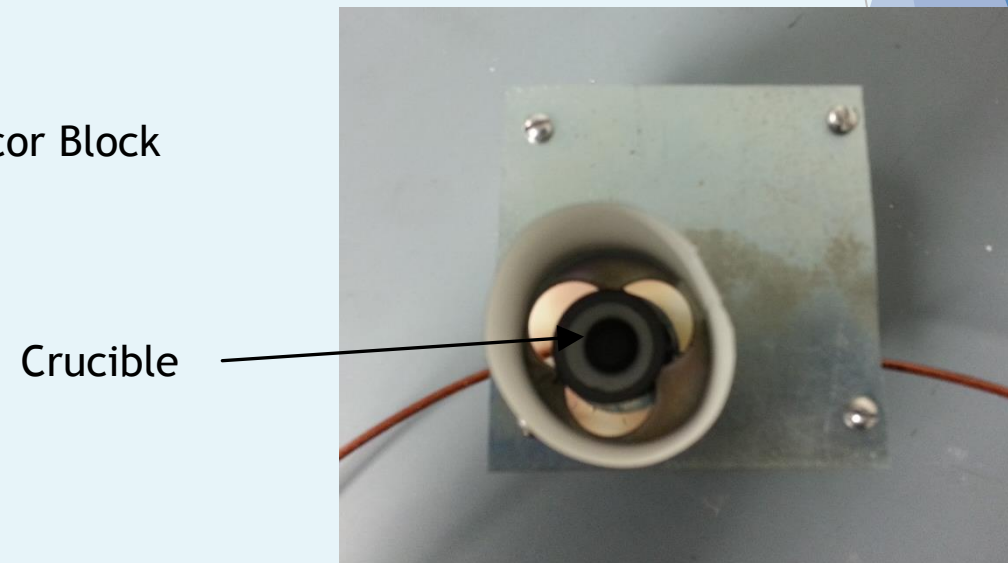
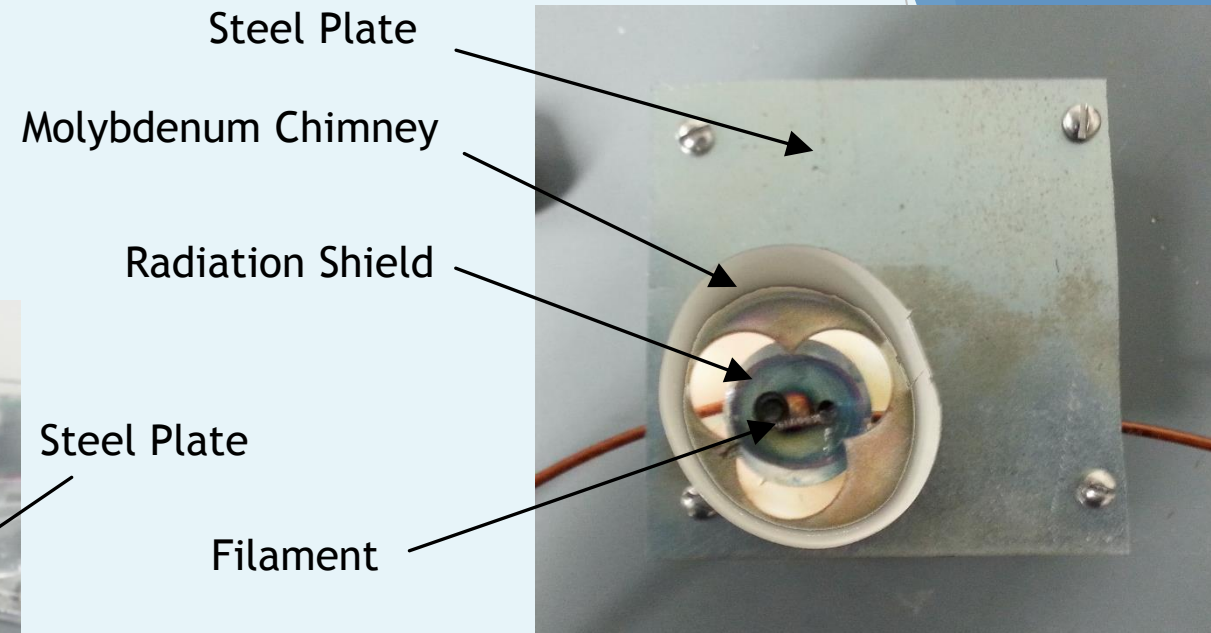
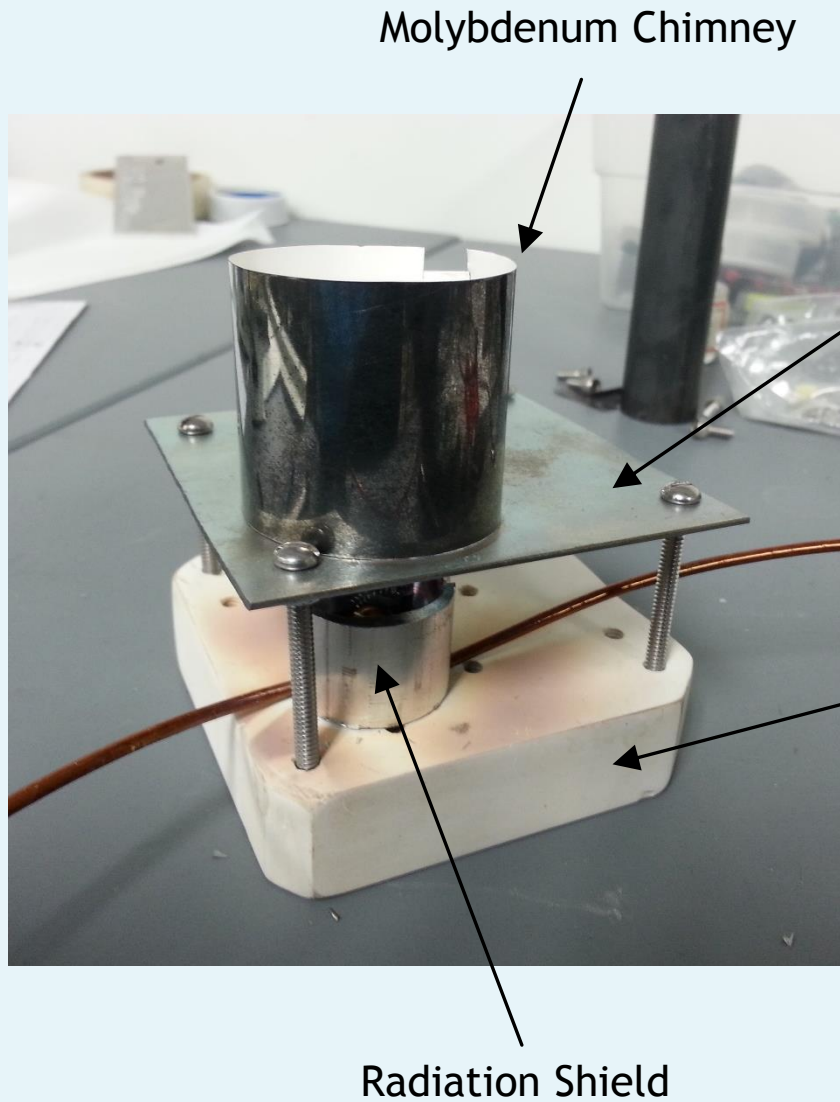


Evaporator

► New Design

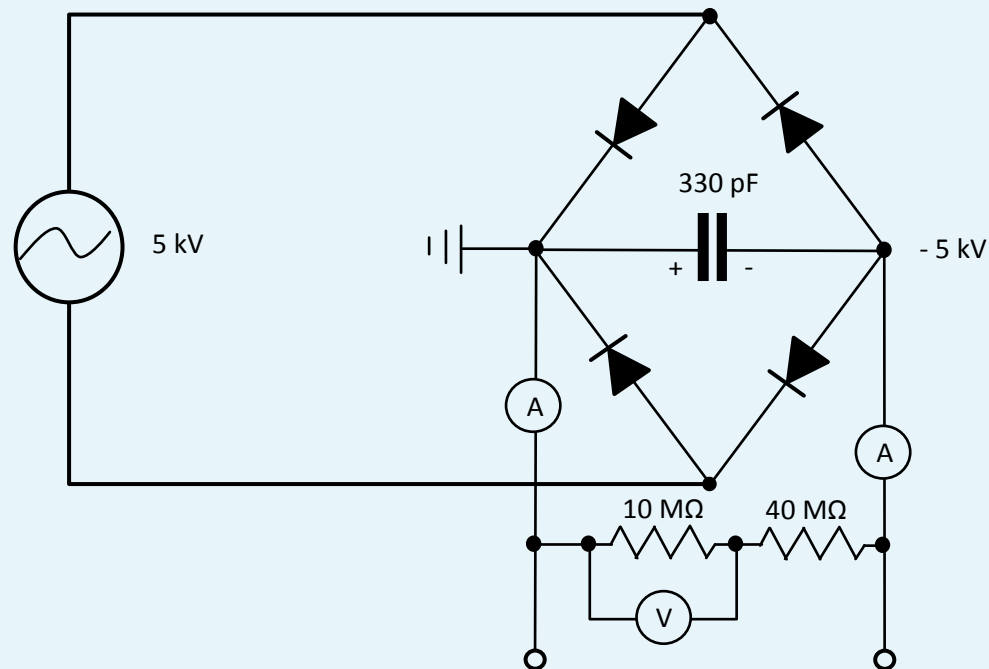


Evaporator

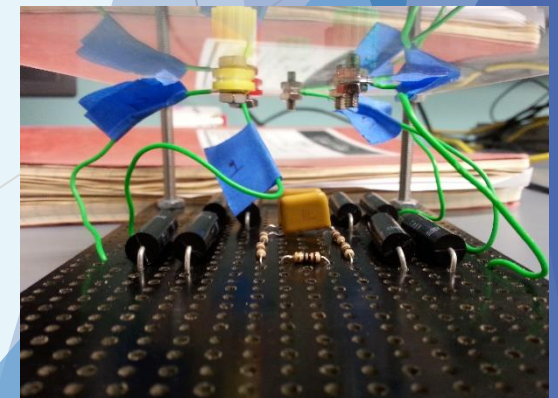
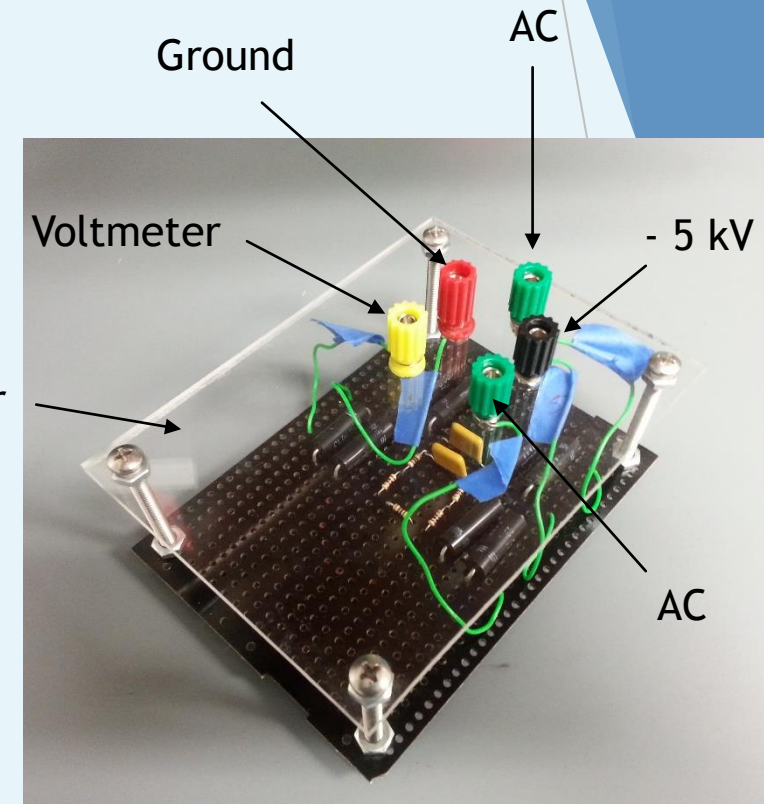


Transformer

- Issues achieving power from High voltage source
- The solution



Plexiglass Cover



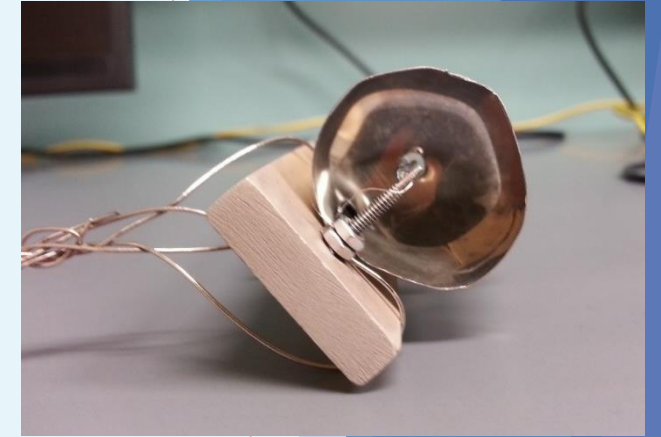
Rate Monitor

- ▶ QCM
- ▶ Evaporation Rate Monitor

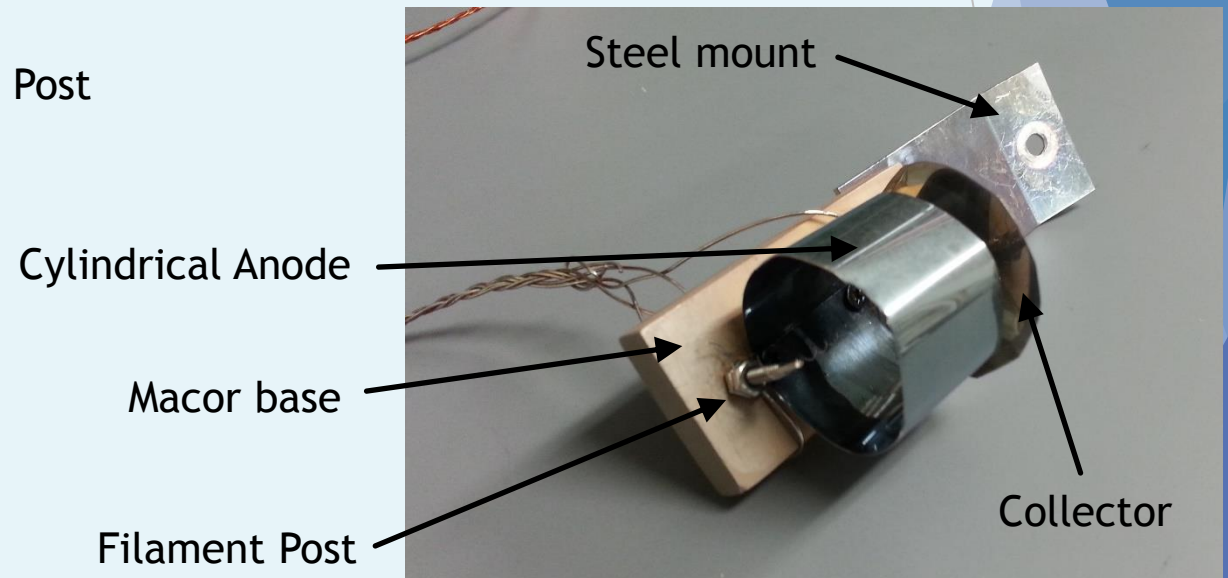
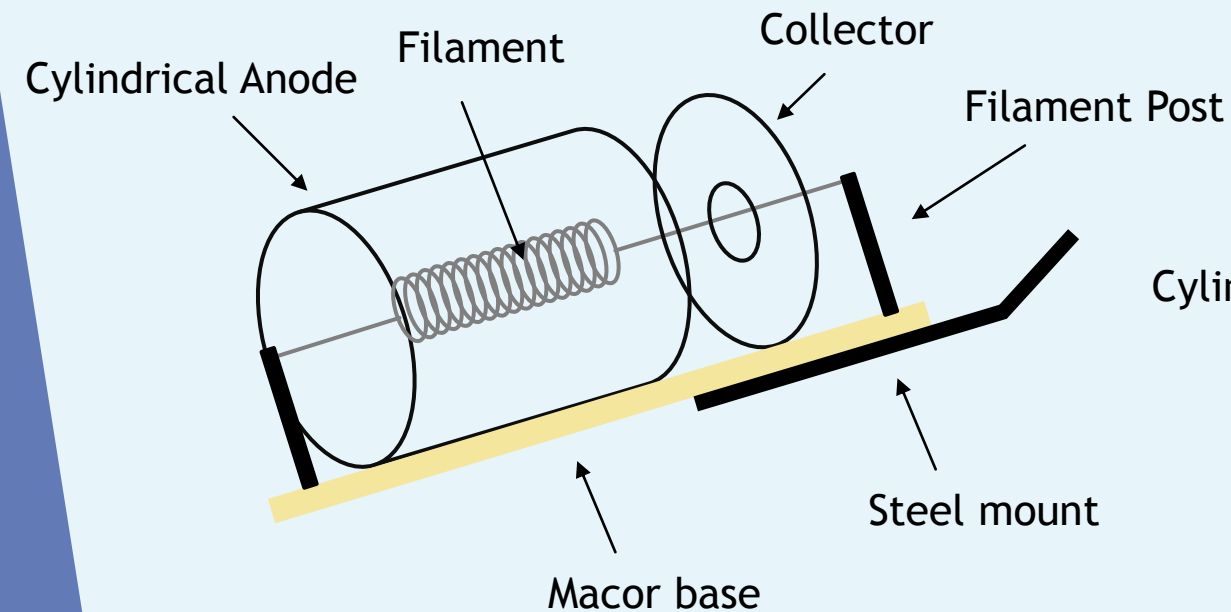
- ▶ G.R. Giedd and M.H. Perkins (1960)



ERM mounted half way up deposition chamber wall.

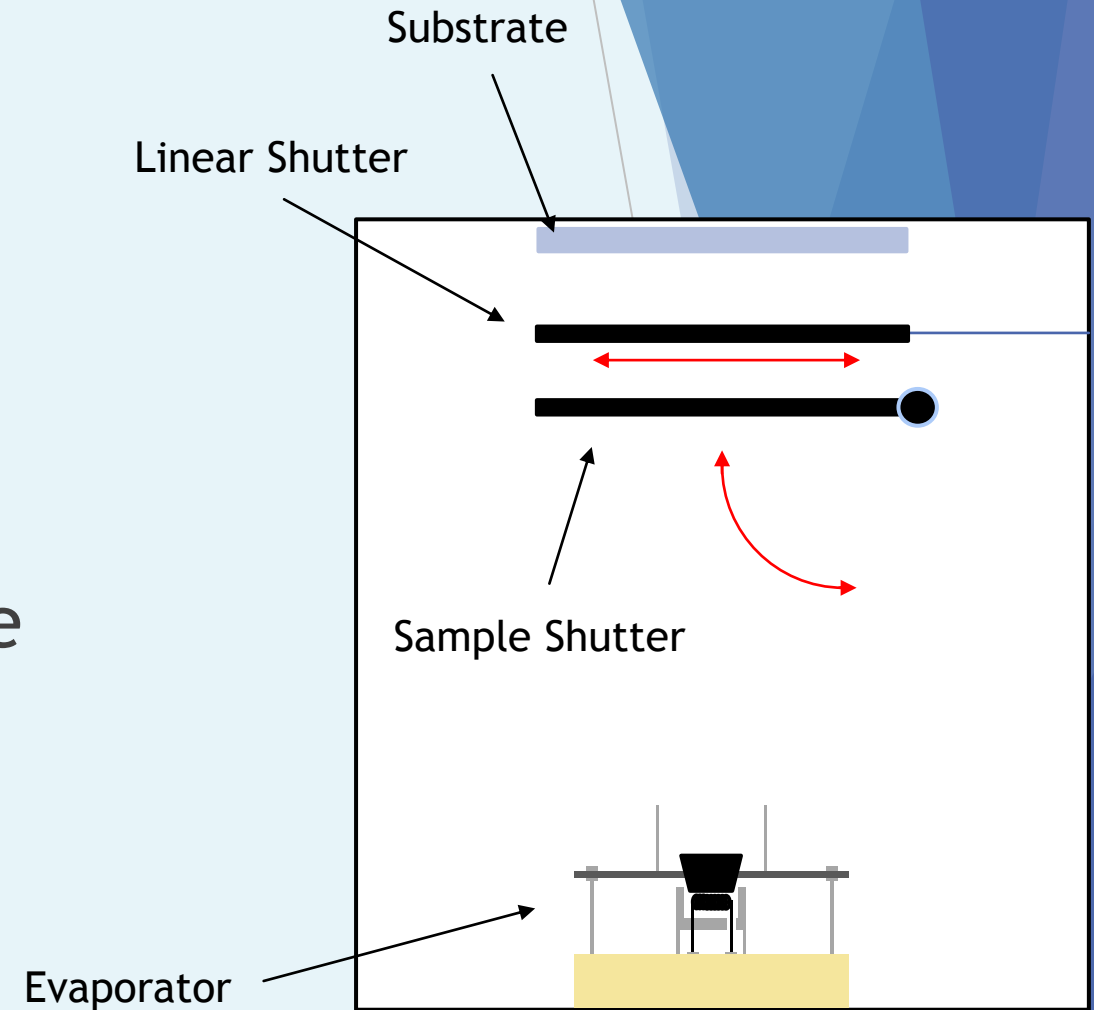


View of ERM looking straight into anode cylinder



Shutters

- ▶ Shutter to create gradient sample
 - ▶ Linear feedthrough
- ▶ Shutter to completely cover sample
 - ▶ Rotary feedthrough



Current Status

- ▶ Most recent Evaporator design is working
- ▶ Can make films of a single thickness
- ▶ Need to refine rate monitor
- ▶ Use Ion mill to clean substrate before deposition
- ▶ Use Ion pump to maintain High Vacuum